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CONFIRMATION NO. 7236

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| SERIAL NUMBER 10/554,380 | FILING or 371(c) DATE 09/29/2006 RULE | CLASS 430 | GROUP ART UNIT 1795 | ATTORNEY DOCKET NO. SHIGA7.032APC |
| APPLICANTS Takuma Hojo, Kawasaki-shi, JAPAN; Kiyoshi Ishikawa, Kawasaki-shi, JAPAN; Tsuyoshi Nakamura, Kawasaki-shi, JAPAN; Tasuku Matsumiya, Kawasaki-shi, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/05804 04/22/2004 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2003-125241 04/30/2003 | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/21/2006 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/ANCA EOFF/</u> Examiner's Signature | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 0 | TOTAL CLAIMS 13 |
| INDEPENDENT CLAIMS 1 | | | | |
| ADDRESS KNOBBE MARTENS OLSON & BEAR LLP 2040 MAIN STREET FOURTEENTH FLOOR IRVINE, CA 92614 UNITED STATES | | | | |
| TITLE Positive photoresist composition and method for forming resist pattern | | | | |
| FILING FEE RECEIVED 1030 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |